Application/Control No.	Applicant(s)/Patent under Reexamination		
10/533,349	FARRELL ET AL.		
Examiner	Art Unit		
Mohamed Charioui	2857		

Mohamed Charioui

SEARCHED				
Class	Subclass	Date	Examiner	
702	8, 40, 49, 57, 60, 64, 65	12/5/2006	мс	
702	75, 79	12/5/2006	МС	
702	80, 107	12/5/2006	МС	
702	179, 182	12/5/2006	мс	
702	183, 184	12/5/2006	мс	
702	189	12/5/2006	МС	
372	20	12/5/2006	мс	
372	29.01	12/5/2006	мс	
374	183	12/5/2006	МС	

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
East: (degradat\$6 with tun\$6 with laser) and calibrat\$6 and (structure with (laser or diode\$1)) and wavelength and	12/5/2006	MC .		
(current with diode\$1)	12/5/2006	MC		
East: (degradat\$6 with tun\$6 with laser) and (calibrat\$6 or adjust) and (laser or diode\$1) and wavelength and	12/5/2006	мс		
(current with diode\$1)	12/5/2006	МС		
IEEE search	12/5/2006	МС		
IEEE: Search by inventor's name	12/5/2006	МС		